



RECEIVED
JUN 19 2003
TC 1700

MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE

PATENT
3430-0140P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: AHN, Byung Yong Conf.: 3449
Appl. No.: 09/747,928 Group: 1765
Filed: December 27, 2000 Examiner: Binh X. Tran
For: DRY ETCHING METHOD AND APPARATUS FOR USE IN THE LCD
DEVICE

#10
Hedg
6/22/03
(NE)

REQUEST FOR RECONSIDERATION

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 16, 2003

Sir:

In response to the Examiner's final Office Action dated March 14, 2003, the following remarks are respectfully submitted in connection with the above-identified application.

REMARKS

Applicant thanks the Examiner for the very thorough consideration given the present application.

Claims 7-17, 19 and 20 are now present in this application. Claims 7, 15, 17 and 20 are independent. Reconsideration of this application is respectfully requested.